



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Sunji ICHIKAWA

Serial No. NEW

Filed January 26, 2004

COPY

Attn: APPLICATION BRANCH

Attorney Docket No. 2004-0095A

LEAD FRAME, MANUFACTURING  
METHOD OF THE SAME, AND  
SEMICONDUCTOR DEVICE USING THE  
SAME

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant in the above-entitled application hereby claims the date of priority under the International Convention of Japanese Patent Application No. 314581/2003, filed September 5, 2003, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Application is submitted herewith.

Respectfully submitted,

Sunji ICHIKAWA

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